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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 2

Complete if Known

Application Number 09/826,583
Filing Date 04/06/01
First Named Inventor Marc A. Unger
Group Art Unit 1772
Examiner Name Unassigned
Attorney Docket Number 20174-003010US

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U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. 1	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code 2 (if known)			
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		Office ³	Number ⁴	Kind Code ⁵ (if known)			
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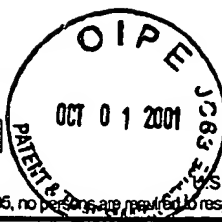
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 3

Complete If Known

Application Number	09/826,583
Filing Date	04/06/01
First Named Inventor	Marc A. Unger
Group Art Unit	1772
Examiner Name	Unassigned
Attorney Docket Number	20174-003010US

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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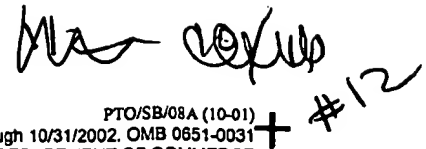
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Application Number	09/826,583
Filing Date	April 6, 2001
First Named Inventor	Unger et al.
Art Unit	3753
Examiner Name	Chambers, A.M.
Attorney Docket Number	20174C-003010US

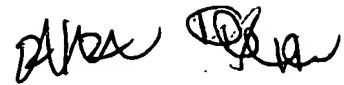
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Filing Date	April 6, 2001
First Named Inventor	Unger et al.
Art Unit	3753
Examiner Name	Chambers, A.M.
Attorney Docket Number	20174C-003010US

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Sheet	2	of	2
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Sheet	1
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of

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Application Number

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09/826,583

Filing Date

April 6, 2001

First Named Inventor

Marc A. Unger

Art Unit

3753

Examiner Name

Michael A. Chambers

Attorney Docket Number

20174C-003010US

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FOREIGN PATENT DOCUMENTS

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